Search Notes



Application/Control No.	Applicant(s)/Patent Under Reexamination
10598997	NAKAMURA ET AL.
Examiner	Art Unit
Mark L Shevin	1793

SEARCHED					
Class	Subclass	Date	Examiner		
148	408, 425, 674	11/03/2008 and	MLS		
		11/08/2008			
204	298.12, 298.13	11/03/2008	MLS		
420	435, 436	11/03/2008	MLS		

SEARCH NOTES				
Search Notes	Date	Examiner		
Inventor name search (EAST, eDan, and Google Scholar)	11/03/2008	MLS		
Assignee name search (Nippon Mining)	11/03/2008	MLS		
IPC: C22C 19/07, C23C 14/34,35, H01F 41/18, H01L 21/285, C22F 1/10	11/03/2008 and 11/08/2008	MLS		
Derwent: M13-G02A , M26-B08	11/03/2008	MLS		
Search reports and written opinions for instant application and co-pending 10-598,502	11/03/2008	MLS		
NPL search for Co-Cr-Pt-B sputterring target, lathe machining of targets, and surface roughness / polishing of targets	11/03/2008	MLS		
Discussion with Jessee Roe about claims	11/03/2008	MLS		
Updated search (US classes, IPC, Derwent, Inventor and Assignee name search)	05/07/2009	MLS		
Updated search (US classes, IPC, Derwent, Inventor and Assignee name search)	12/08/2009	MLS		

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

/Mark L. Shevin/	

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